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Sheet

1

of

Application Number

Filing Date

01/23/2004

First Named Inventor

TADAHIRO OHMI

Art Unit

2818

Examiner Name _____

Attorney Docket Number

040258-0307828

[illegible]

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ^o
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
DV	F	JP 9-223752	08-00-1997	MINE		
PV	G	JP PCT/JP01/01967	03-00-2001			

Shuland

Date _____

Considered

09/07/05

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PTO/SB/08b (08-03)

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Application Number	
Filing Date	01/23/2004
First Named Inventor	TADAHIRO OHMI
Art Unit	2818
Examiner Name	
Attorney Docket Number	040258-0307828

Sheet 1 of 1

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
DV	1	ITO ET AL., "Silicon Oxynitridation With Inductively Coupled Oxygen-Nitrogen Mixed Plasma," Jpn. J. Appl. Phys., p. 612-616, (1997).	
DV	2	HIRAYAMA ET AL., "Low Temperature Growth of High-Integrity Silicon Oxide Films by Oxygen Radical Generated in High-Density Krypton-Plasma," IEEE, p. 249-252, (1999).	
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Examiner Signature	<i>Richard</i>	Date Considered	09/07/05
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Application Number	10/762520
Filing Date	01/23/2004
First Named Inventor	TADAHIRO OHMI
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(Use as many sheets as necessary)

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		Country Code ³ Number ⁴ Kind Code ⁵ (If known)				
DV	A	JP 5-267684	10-00-1993	OZAWA		
DV	B	JP 259-105371	06-00-1984	KOMORI		
DV	C	JP 8-51164	02-00-1996	MORITA		
DV	D	JP 9-205155	08-00-1997	TAKABAYASHI		
DV	E	JP 9-213820	08-00-1997	USHIYAMA et al.		

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